



UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q80755

Kesahiro KOIKE

Appln. No.: 10/809,523

Group Art Unit: 1765

Confirmation No.: 7526

Examiner: Lan Vinh

Filed: March 26, 2004

For:

METHOD OF PRODUCING A GLASS SUBSTRATE FOR A MASK BLANK AND

METHOD OF PRODUCING A MASK BLANK

INFORMATION DISCLOSURE STATEMENT UNDER 37 C.F.R. §§ 1.97 and 1.98

MAIL STOP AMENDMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In accordance with the duty of disclosure under 37 C.F.R. § 1.56, Applicant hereby notifies the U.S. Patent and Trademark Office of the documents which are listed on the attached PTO/SB/08 A & B (modified) form and/or listed herein and which the Examiner may deem material to patentability of the claims of the above-identified application.

One copy of each of the listed documents is submitted herewith, except for the following: U.S. patents and/or U.S. patent publications; and co-pending non-provisional U.S. applications filed after June 30, 2003.

The present Information Disclosure Statement is being filed after the later of three months from the application's filing date and the mailing date of the first Office Action on the merits, but before a Final Office Action, Notice of Allowance, or an action that otherwise closes prosecution in the application (whichever is earlier), and therefore Applicant is filing concurrently herewith a Statement Under 37 C.F.R. § 1.97(e). No fee under 37 C.F.R. § 1.17(p) is required.

INFORMATION DISCLOSURE STATEMENT

U.S. Appln. No.: 10/809,523.

In compliance with the concise explanation requirement under 37 C.F.R. § 1.98(a)(3) for

foreign language documents, Applicant encloses herewith a copy of a Communication from a

foreign patent office in a counterpart application citing such documents, together with an

English-language version (if not already included) of at least that portion of the Communication

indicating the degree of relevance found by the foreign patent office.

The submission of the listed documents is not intended as an admission that any such

document constitutes prior art against the claims of the present application. Applicant does not

waive any right to take any action that would be appropriate to antedate or otherwise remove any

listed document as a competent reference against the claims of the present application.

The USPTO is directed and authorized to charge all required fees, except for the Issue

Fee and the Publication Fee, to Deposit Account No. 19-4880. Please also credit any

overpayments to said Deposit Account.

Respectfully submitted,

Registration No. 25,426

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washington office 23373
CUSTOMER NUMBER

Date: April 14, 2006



PATENT APPLICATION

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STATEMENT UNDER 37 C.F.R. § 1.97(e)

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

The undersigned hereby states, upon information and belief:

That each item of information contained in the Information Disclosure Statement filed concurrently herewith was first cited in any communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of said Information Disclosure Statement.

Respectfully submitted,

Alan J. Kasper

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washington office 23373 customer number

Date: April 14, 2006

Application Number 10/809,523 Confirmation Number 7526 STATEMENT BY APPLICANT Filing Date March 26, 2004 First Named Inventor Kesahiro KOIKE (use as many sheets as necessary) APR 14 2006 Examiner Name Lan Vinh	Substitute for Form 144	O A & R/PTO		Complete if Known		
STATEMENT BY APPLICANT (use as many sheets as necessary) APR 14 2006 Filing Date March 26, 2004 First Named Inventor Kesahiro KOIKE Art Unit 1765 Examiner Name Lan Vinh				Application Number	10/809,523	
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Examiner Name Lan Vinh			7 . 8	First Named Inventor	Kesahiro KOIKE	
Examiner Name Lan Vinh	` (use	as many shee	ets as necessary) APR 14 2006	Art Unit	1765	
	•	•	\ a	Examiner Name	Lan Vinh	
Sheet l of Attorney Docket Number Q80755	Sheet	1	of of	Attorney Docket Number	Q80755	

U.S. PATENT DOCUMENTS					
Evaminar	Cite	Document		Publication Date MM-DD-YYYY	
	No.1	Number	Kind Code ² (if known)		Name of Patentee or Applicant of Cited Document
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FOREIGN PATENT DOCUMENTS							
Examiner Cite Initials* No.1	Foreign Patent Document			Publication Date	Name of Patentee or		
		Country Code ³	Number ⁴	Kind Code ⁵ (if known)	MM-DD-YYYY	Applicant of Cited Document	Translation ⁶
		JP	2001-070898	Α	03-21-2001	SHINETSU CHEMICAL CO	Abstract
		WO	02/10729	Al	02-07-2002	SILICON VALLEY GROUP, INC.	
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NON PATENT LITERATURE DOCUMENTS				
Cite No.1	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city, and/or country where published.	Translation ⁶		
		 		
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Examiner Signature	Date Considered

^{*}EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹Applicant's unique citation designation number (optional). ²See Kind Codes of USPTO Patent Documents at www.uspto.gov, MPEP 901.04 or in the comment box of this document. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST. 3). ⁴For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. ⁶ Applicant is to indicate here if English language Translation is attached.